| ZUOY E MAS SALL MELLING | Monday Sept. 14th | Tuesday | Sept. 15th | Wednesday | Sept. 16th | Thursday | Sept. 17th |
|-------------------------|--------------------------------------------------------------------------------------------------------------------------------------------------------------|------------------------------------------------------|--------------------------------------------------------------------------------------------------------------------------------|-----------------------------------------------------------------------------------|-------------------------------------------------------------------------------------------------|----------|------------|
| 08:30 | | | T. Shubina K2 (I5) InN/In nanocomposites: plasmonic effects and optical properties | | F. Bechstedt K4 (113) Spectral properties of InN and related compounds from first principles W1 | | |
| 09:00 | | | | | | | |
| 09:15 | | grown by molecular be tem J. Raethel (O7) Optical a |) Investigation of InN layers eam epitaxy on Si or GaN uplates unisotropy of a- and m-plane landing GaN substrates | I. Gorczyca (I14) In-segreg behavior of band gap and i InAIN and InGaN. The | its pressure coefficient in | | |
| | | | tical properties of InN grown 1) substrate | | | | |
| 10:00 | 10:00 Opening & planary accessor | characterization of InN a | s) MOVPE growth and and related heterostructures | C. Van de Walle K5 (115) S bulk and sui | | | |
| 10:30 | 10:00 Opening & plenary session | | Coffee Bre | ak (20 min) | | | |
| 11:00 | Briot (I7) Recent advances in the MOVPE growth of Indium Nitride A. Yoshikawa K6 (I16) Recent advances and challenges in p-type doping of InN and InN-based | | | challenges in p-type doping of InN and InN-based | | | |
| | | | | | | | |
| 11:30 | | optical properties of high- | quality InN on GaN-template | | | | |
| | | A. Yamamoto K3 (I8) Rea | A. Yamamoto K3 (I8) Recent Advances in InN-based Solar Cells; Status and Challenges in InGaN and InAIN Solar Cells | | | | |
| 12:00 | | Solar Cells; Status and | | J. Speck (I18) Progress in | the MBE Growth of InN | | |

| 12:30 | Lunch Break | | | | | | |
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| 14:00 | W. Walukiewicz K1 (I1) Applications of group III- nitride alloys for multijunction solar cells | T. Yamaguchi (I9) Growth of InN and Related Alloys Using Droplet Elimination by Radical Beam Irradiation N. Kaufmann (O11) Study on Indium Gallium Nitride Quantum Wells: A Comparison between MBE grown and MOVPE grown Quantum Wells | H. Morkoc K7 (I19) New Twists in LEDs and HFETs based on Nitride Semiconductors W4 | | | | |
| 14:45 | J.M. Routoure (O1) Low frequency noise measurements in InN films | C. Rauch (O12) In-vacancies in Si-doped InN | | | | | |
| | M.A. Poisson (I2) LPMOCVD growth of InAIN/GaN HEMT heterostructures. Comparison of composite SiCopSiC and bulk SiC substrates for HEMT device applications | Inushima (I10) Meissner effect of superconducting InN | D. Cavalcoli K8 Capacitance and surface voltage charge techniques W5 | | | | |
| 15:30 | Coffee Break (20 min) | | | | | | |
| 15:50 16:20 | C. Wentzel (I3) Wavelength-Stable Green Light Emitting Diodes in Non-Polar GalnN/GaN Quantum Well Growth | C.L Wu (I11) Cross-sectional scanning photoelectron microscopy/spectroscopy studies on the electronic structures of InN surface and interface | R. Butté K9 Optical properties of low-dimensional nitride semiconductors W6 | | | | |
| 16:35 | P. Komninou (O2) Microstructure of InN grown on Si (111) by plasma-assisted MBE using a double buffer layer | A. Eisenhardt (O12) Changes in the valence band structure of as-grown InN(0001) surfaces upon exposure to oxygen and water | | | | | |
| 16:50 | Y. Ishitani (O3) Effects of threading dislocations and other defects on reduction of band-edge photoluminescence in n-InN films | B. Hourahine (O13) Vacancies in InN and In rich InGaN | | | | | |
| 17:05 | of InN layers | X. Wang (O14) Polarity determination of InN by using circular photogalvanic effect | R. Goldhan K10 Optical properties of bulk-like nitride semiconductors W7 | | | | |
| N | M. Zhu (O5) Inclined Dislocation Pair Formation as a Mechanism of Partial Strain Relaxation in GalnN/GaN Quantum Wells on Low-Dislocation Density Bulk GaN | C. Friedrich (O15) Preparation and surface structure of InN(0001) and In_{x}Ga_{1-x}N(0001) surfaces | | | | | |
| 17:35 | A. Kikuchi (I4) InGaN/GaN nanocolumn LEDs and selective area growth of GaN nano-crystals by rf-plasma assisted molecular beam epitaxy | M.A. Sanchez (I12) MBE growth and characterization of InN-based layers and nanostructures for infrared applications | | | | | |
| | plasma assisted molecular beam epitaky | applications | | | | | |